

APPLICATION UNDER UNITED STATES PATENT LAWS

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Invention: SEMICONDUCTOR LASER APPARATUS, SEMICONDUCTOR LASER CONTROL METHOD, AND IMAGE DISPLAYING APPARATUS

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SPECIFICATION

TITLE OF THE INVENTION

SEMICONDUCTOR LASER APPARATUS, SEMICONDUCTOR LASER
CONTROL METHOD, AND IMAGE DISPLAYING APPARATUS

CROSS-REFERENCE TO RELATED APPLICATION

5 This application is based upon and claims the
benefit of priority from the prior Japanese Patent
Application No. 2002-347506, filed November 29, 2002,
the entire contents of which are incorporated herein by
reference.

10 BACKGROUND OF THE INVENTION

1. Field of the Invention

 This invention relates to a semiconductor laser
apparatus and a semiconductor laser control method
which connect the light emitted from a semiconductor
15 laser to an optical fiber at high efficiency with high
light density. This invention also relates to a
projection-type image displaying apparatus using the
semiconductor laser apparatus as a light source.

2. Description of the Related Art

20 In recent years, tremendous development effort has
been directed toward using a semiconductor laser as a
light source for a projection-type image displaying
apparatus, such as a liquid-crystal projector.

 In this type of image displaying apparatus, the
25 light emitted from the semiconductor laser that
generates as high an optical output as several watts to
ten watts is caused to enter an optical fiber

constituting a fiber laser, thereby producing visible light with high light density to display images.

Generally, a semiconductor laser goes into a multi-mode, when generating a high output, and has a long, narrow emitting region. For example, the emitting region of a semiconductor laser that generates a 1-W output is 100 μm long in the slow axis direction and 1 μm long in the fast axis direction.

The light emitted from such a semiconductor laser is radiated, for example, with a divergence angle of $\pm 4^\circ$ in the slow axis direction and $\pm 20^\circ$ in the fast axis direction with respect to the optical axis perpendicular to the emitting region surface.

It is assumed that the light-receiving angle of the optical fiber which the emitted light from the semiconductor laser is caused to enter is symmetry with respect to the optical axis and is 20° in both of the slow axis direction and the fast axis direction.

When the emitted light from the semiconductor laser is adjusted via a lens to the light-receiving angle of the optical fiber, the beam diameter fulfills a sine condition (the relationship between the beam diameter D and the divergence angle θ : $D \sin \theta = \text{constant}$). Consequently, the beam diameter is 40 μm long in the slow axis direction and 2 μm long in the fast axis direction and therefore is in the form of a long, narrow shape.

Since the core cross-sectional shape of the optical fiber is generally circular, a core diameter of 40 μm is necessary to cause all the light with such a long, narrow beam diameter to enter the optical fiber.

5 With such a core diameter, all the light emitted from the semiconductor laser can be caused to enter the optical fiber. However, because the light enters the optical fiber with a good margin in the fast axis direction, the light density (incident light
10 power/optical fiber core cross-sectional area of the incident light decreases. Specifically, to project light with a high light density, it is desirable that the core cross-sectional shape of the optical fiber should be equal to the beam diameter.

15 U.S. Pat. No. 5,677,920 has disclosed an example where the cross-sectional shape of the inner clad to which excitation light is inputted is made rectangular in a double clad fiber used in an optical fiber laser.

 However, the following problem arises: not only an
20 optical fiber whose core cross section is rectangular is very difficult to manufacture, but also an ordinary optical fiber whose cross section is circular cannot be connected easily to an optical fiber whose cross section is rectangular.

25 Patent document 1 has also disclosed an example of stacking a plurality of optical fibers whose cross section is rectangular one on top of another and

optically connecting the resulting fiber to another optical fiber, taking into account a case where a plurality of optical fiber outputs are combined and the resulting output is optically connected to another optical fiber.

This approach, however, requires not only a high-degree of alignment when stacking optical fibers one on top of another but also the designing of the resulting optical fiber according to the shape of the optical fiber to which the former is to be connected. Therefore, the configuration cannot be said to be practical.

As described above, when an optical fiber whose core cross-sectional shape is circular is used, it has been difficult to cause the light emitted from a multi-mode semiconductor laser to enter an optical fiber at high efficiency with high light density.

Furthermore, when an optical fiber whose core cross-sectional shape is rectangular is used, the following problem arises: such an optical fiber is not only difficult to manufacture but also impossible to connect easily to an ordinary optical fiber whose cross section is round.

In addition, when a plurality of optical fibers whose core cross-sectional shape is rectangular are combined and the resulting optical fiber is connected optically to another optical fiber, it is necessary to

design the cross-sectional shape according to the optical fiber to which the resulting optical fiber is to be connected. Thus, this approach is unsuitable for practical use.

5

BRIEF SUMMARY OF THE INVENTION

According to an aspect of the present invention, there is provided a semiconductor laser apparatus comprising a semiconductor laser, optical means for converting rays of light emitted from the semiconductor laser into parallel rays of light, and an optical fiber having an incidence end, to which the light passed through the optical means enters, and being changed continuously from a specific position in a middle of the fiber toward the incidence end in such a manner that the core shape at the incidence end becomes elliptic, with the cross-sectional area remaining unchanged.

According to another aspect of the present invention, there is provided a semiconductor laser control method comprising a step of converting rays of light emitted from a semiconductor laser into parallel rays of light, and a step of causing the converted rays of light to enter an optical fiber changed continuously from a specific position in the middle toward an incidence end in such a manner that the core shape at the incidence end becomes elliptic, with the cross-sectional area remaining unchanged.

According to still another aspect of the present invention, there is provided an image displaying apparatus comprising a semiconductor laser apparatus including optical means for converting rays of light emitted from a semiconductor laser into parallel rays of light, and a first optical fiber having an incidence end, to which the light passed through the optical means enters, and being changed continuously from a specific position in the middle toward the incidence end in such a manner that the core shape at the incidence end becomes elliptic, with the cross-sectional area remaining unchanged, a second optical fiber which excites the light emitted from the first optical fiber of the semiconductor laser apparatus, modulation means for modulating spatially the light exited by the second optical fiber, on the basis of an image signal, and display means for projecting the optical output obtained from the modulation means on a screen to display the output.

BRIEF DESCRIPTION OF THE SEVERAL VIEWS OF THE DRAWING

FIG. 1 is a diagram to help explain a first embodiment of the present invention;

FIG. 2 is a diagram to help explain a second embodiment of the present invention;

FIG. 3 is a diagram to help explain a third embodiment of the present invention;

FIG. 4 is a diagram to help explain a fourth

embedment of the present invention;

FIGS. 5A to 5D are diagrams to help explain the main part of the fourth embodiment in detail;

FIG. 6 is a diagram to help explain a fifth
5 embedment of the present invention; and

FIG. 7 is a diagram to help explain a sixth embedment of the present invention.

DETAILED DESCRIPTION OF THE INVENTION

Hereinafter, referring to the accompanying
10 drawings, embodiments of the present invention will be explained in detail. FIG. 1 is a schematic diagram of a semiconductor laser apparatus to be explained in a first embodiment of the present invention. In FIG. 1, numeral 11 indicates a semiconductor laser. A long,
15 narrow emitting region 12 is formed at one end of the semiconductor laser 11.

The light emitted from the emitting region 12 of the semiconductor laser 11 is collimated in the fast axis direction by a cylindrical lens 13. The
20 collimated light is further collimated in the slow axis direction by a cylindrical lens 14 and then enters an optical fiber 15.

An incidence end part (fiber end portion) 16 of the optical fiber 15 is changed continuously into a
25 tapered form in such a manner that the part is pressed or crushed gradually along the diameter from a specific position in the middle toward the end (like a tapered

figure) so that the core cross section may take the form of an ellipse (which could be a warped ellipse, defective circle, or round-edge plate), with the cross-sectional area remaining unchanged.

5 For example, when the core cross-sectional shape of the incidence end part 16 is $20 \times 5 \mu\text{m}$, the taper length is 10 mm. When the core cross-sectional shape of the incidence end part 16 is $40 \times 10 \mu\text{m}$, the taper length is 20 mm.

10 The cylindrical lenses 13, 14 are so designed that an emitting region 12 of the semiconductor laser 11 and the core cross-sectional shape of the incidence end part 16 of the optical fiber 15 (or the shape of an exterior side of the fiber end portion) have a
15 conjugate relationship with each other.

 Here, the core cross-sectional shape of the incidence end part 16 will be explained. Let the length of the emitting region 12 of the semiconductor laser 11 in the slow axis direction be $D_{\text{slow_LD}}$ and the
20 length of the emitting region 12 in the fast axis direction be $D_{\text{fast_LD}}$. Additionally, let the divergence angle of the emitted light from the semiconductor laser 11 be $\theta_{\text{slow_LD}}$ in the slow axis direction and $\theta_{\text{fast_LD}}$ in the fast axis direction.

25 Furthermore, let the beam diameter on the incidence end part 16 of the optical fiber 15 be $D_{\text{slow_FB}}$ in the slow axis direction and $D_{\text{fast_FB}}$ in the

fast axis direction. Let the divergence angle be $\theta_{\text{slow_FB}}$ in the slow axis angle and $\theta_{\text{fast_FB}}$ in the fast axis angle.

Then, under sine conditions, the following
5 equations hold:

$$D_{\text{slow_LD}} \cdot \sin(\theta_{\text{slow_LD}}) = D_{\text{slow_FB}} \cdot \sin(\theta_{\text{slow_FB}}) \cdots (1)$$

$$D_{\text{fast_LD}} \cdot \sin(\theta_{\text{fast_LD}}) = D_{\text{fast_FB}} \cdot \sin(\theta_{\text{fast_FB}}) \cdots (2)$$

Since the light-receiving angle of the optical
fiber 15 is symmetric with respect to the optical axis,
10 it is desirable that the divergence angle of the light
emitted from the semiconductor laser 11 should be
symmetric with respect to the optical axis at the time
when the light enters the optical fiber 15.

When the incidence end part 16 converts the
15 divergence angle by use of the cylindrical lenses 13,
14 so that the divergence angle in the slow axis
direction may become equal to the divergence angle in
the fast axis angle, since $\theta_{\text{slow_FB}} = \theta_{\text{fast_FB}}$, the
ratio of the beam diameter at the incidence end part 16
20 in the slow axis direction to that in the fast axis
direction is expressed as:

$$\begin{aligned} & D_{\text{slow_FB}} / D_{\text{fast_FB}} \\ &= [D_{\text{slow_LD}} \cdot \sin(\theta_{\text{slow_LD}})] / [D_{\text{fast_LD}} \cdot \sin(\theta_{\text{fast_LD}})] \\ & \cdots (3) \end{aligned}$$

25 It is desirable that the major axis/minor axis
ratio of the ellipse at the core cross section is set
according to equation (3).

To cause the emitted light from the semiconductor laser 11 to enter the optical fiber with as high a light density as possible, the cross-sectional shape of the core cross section has only to be determined using equations (1) and (2), provided that $\theta_{\text{slow_FB}} = \theta_{\text{fast_FB}}$ = the maximum light-receiving angle of the optical fiber.

The optical fiber 15 is such that the core cross section changes continuously from an ellipse to a regular circle, starting from the incidence end part 16 toward the inner part. Consequently, when the light entering the incidence end part 16 advances in the optical fiber 15, as the shape of the light gets closer to a regular circle along the major axis of the ellipse, the diameter of the light decreases, with the result that the divergence angle tends to become larger. As the shape of the light gets closer to a regular circle along the minor axis of the ellipse, the diameter of the light increases, with the result that the divergence angle tends to become smaller.

However, in the optical fiber 15, the side of the core is inclined with respect to the major and minor axes of the ellipse. Therefore, when light is reflected in the core a plurality of times, this causes the tendency of the divergence angle to increase and the tendency of the divergent angle to decrease to offset each other, with the result that the divergence

angle remains unchanged if the area of the ellipse and that of the regular circle are constant.

This enables the beam diameter to be converted from an ellipse to a regular circle with the divergence angle of light remaining unchanged. This effect makes it possible to cause the light emitted from the semiconductor laser 11 to enter the optical fiber 15 with a circular core cross section at high efficiency with high light density.

FIG. 2 shows a second embodiment of the present invention. In FIG. 2, the same parts as those in FIG. 1 are indicated by the same reference numerals. In the second embodiment, the semiconductor laser apparatus explained in the first embodiment is used to input excitation light to an optical fiber laser.

In FIG. 2, numeral 17 indicates an optical fiber to whose core a laser activating material is added, numeral 18 indicates a reflecting element that permits the light (excitation light) emitted from the semiconductor laser 11 to pass through and reflects the laser light generated at the optical fiber 17, and numeral 19 indicates a reflecting element that reflects part of the laser light generated at the optical fiber 17. In FIG. 2, (a) to (d) show cross-sectional shapes in various places of the optical fibers 15, 17.

Specifically, for example, the wavelength of the semiconductor laser 11 is 830 to 850 nm. The laser

activating material in the core of the optical fiber 17 may be $\text{Pr}^{3+}/\text{Yb}^{3+}$. The reflecting element 18 permits all the light with a wavelength of 830 to 850 nm to pass through and reflects all the light with a

5 wavelength of 635 nm. The reflecting element 19 reflects part of the light with a wavelength of 35 nm.

The excitation light with a wavelength of 830 to 850 nm emitted from the semiconductor laser 11 passes through the cylindrical lenses 13, 14 and the optical
10 fiber 15 and enters the optical fiber 17. The excitation light is absorbed by $\text{Pr}^{3+}/\text{Yb}^{3+}$ in the optical fiber 17, thereby generating light with a wavelength of 635 nm.

From the generated light with a wavelength of
15 635 nm, a resonator provided between the reflecting elements 18 and 19 produces laser light with a wavelength of 635 nm and outputs the laser light at the reflecting element 19. The excitation light of the optical fiber laser requires a high output and a high
20 light density. Use of the semiconductor laser apparatus of the first embodiment enables the optical fiber laser to be realized.

FIG. 3 shows a third embodiment of the present invention. In FIG. 3, the same parts as those in
25 FIG. 2 are indicated by the same reference numerals. The third embodiment differs from the second embodiment in that the core diameter of the optical fiber 15 whose

incidence end part 16 is formed into an ellipse differs from the core diameter of the optical fiber 17 to which a laser activating material is added.

5 As for the optical fiber 15, it is desirable that the core diameter should be determined on the basis of the facility for forming an ellipse. For example, use of a plastic fiber as the optical fiber 15 enables the plastic fiber to be flattened (or made substantially elliptic) by applying pressure to the plastic fiber, 10 while heating the ends of the plastic fiber.

The core diameter of the plastic fiber is generally 100 μm or more. On the other hand, the core diameter of the optical fiber 17 to which a laser activating material is added is several hundred 15 micrometers to several micrometers, depending on the application.

Therefore, both of core diameters do not necessarily coincide with each other. Therefore, in the third embodiment, after the optical fiber 15 20 changes the beam shape from an ellipse to a regular circle, the core diameter of the optical fiber 15 is converted into the core diameter of the optical fiber 17 by use of the lens 20.

Here, the elliptic core of the incidence end part 25 16 of the optical fiber 15 is designed so that the major axis/minor axis ratio may satisfy equation (3). At the same time, the cylindrical lenses 13, 14 are set

so that the shape of the emitting region 12 of the semiconductor laser 11 and the elliptic cross shape of the incidence end part 16 of the optical fiber 15 may have a conjugate relationship with each other.

5 Since the operation of the optical fiber laser in the third embodiment is the same as in the second embodiment, its explanation will be omitted. Conversion means for converting the core diameter is not limited to lens 20. For instance, a taper fiber
10 whose core diameter changes continuously or other optical means may be used.

 FIG. 4 shows a fourth embodiment of the present invention. In FIG. 4, the same parts as those in FIG. 2 are indicated by the same reference numerals.
15 The fourth embodiment differs from the second embodiment in that a plurality of semiconductor laser apparatuses (four semiconductor laser apparatuses in FIG. 4) are arranged in parallel and the individual optical fibers 15 are bundled together and then light
20 is caused to enter the optical fiber 17 to which a laser activating material is added.

 When an output higher than the output of the laser light obtained by the optical fiber laser shown in the second embodiment is needed, arranging more than one
25 configuration of the second embodiment as they are requires a plurality of optical fibers 17 and a plurality of reflecting elements 18, 19.

Furthermore, when the output of the optical fiber laser is connected optically to another optical fiber, a plurality of optical fibers to be connected are needed, leading to an increase in the cost. To avoid
5 this problem, a plurality of optical fibers 15 bundled together are connected optically to the optical fiber 17, thereby reducing the cost.

FIGS. 5A to 5D are sectional views of the portion indicated by (a) in FIG. 4. To bundle the optical
10 fibers 15 together with a high light density, it is desirable that the optical fibers 15 should have a less thickness.

Furthermore, in addition to just bundling the optical fibers 15 together, it is desirable that the
15 end portions of the optical fibers 15 should be so processed that the cores contact each other closely as shown in FIGS. 5B to 5D and have the same shape as the core cross-sectional shape of the optical fiber 17.

The cross-sectional shape of each optical fiber 15
20 in the close contact has to change continuously from a regular circle to any one of the shapes in FIGS. 5B to 5D, with the area remaining unchanged. Since the cross sections of the optical fibers 15 are not necessarily shaped as shown in FIG. 5B or 5C but only the external
25 form of the optical fibers 15 has to be shaped as shown in FIG. 5D, it is easy to process the optical fibers 15.

Since the processed part and the unprocessed part change continuously, with the core cross-sectional area remaining unchanged, the divergence angle of light does not change, which enables optical connection to the optical fiber 17, while retaining the high efficiency and high light density.

FIG. 6 shows a fifth embodiment of the present invention. In FIG. 6, the same parts as those in FIG. 3 are indicated by the same reference numerals. The fifth embodiment is a combination of the third and fourth embodiments. In the fifth embodiment, the difference between the core diameter of the bundled optical fibers 15 and the core diameter of the optical fiber 17 to which a laser activating material is added is corrected by the lens 20.

In the explanation of the above embodiments, when the incidence end part 16 of the optical fiber 15 is processed, the area of the processed part and the area of the unprocessed part are made constant. A vital part of the explanation is the conversion of the beam shape.

Specifically, when the area is constant, the divergence angle is constant at both of the processed part and the unprocessed part. When the area is not constant, the divergent angle changes in inverse proportion to the area ratio of the processed part to the unprocessed part. Therefore, when the divergence

angle is required to change, or the area is also needed to change, the area at the processed part may be made different from that at the unprocessed part.

FIG. 7 shows the configuration of an image
5 displaying apparatus according to a sixth embodiment of the present invention. In the sixth embodiment, the optical fiber laser in one of the second to fifth embodiments is used as a light source for a projection-type image displaying apparatus.

10 In FIG. 7, numerals 21, 22, 23 indicate optical fiber lasers. In the optical fiber lasers 21 to 23, a laser activating material to be added to the optical fiber 17, the oscillation wavelength of the semiconductor laser 11, and others are set so that red,
15 green, and blue laser lights may be obtained by wavelength up-conversion.

Furthermore, numerals 24, 25, 26 indicate optical fibers that output laser light generated at the optical fibers 21, 22, 23, respectively. Numeral 27 indicates
20 a lens, 28 an image input terminal, 29 a liquid-crystal driver, 30 a liquid-crystal panel, 31 a projection lens, and 32 a screen.

The operation of the image displaying apparatus will be explained. The rays of light emitted from the
25 ends of the optical fibers 24 to 26 become parallel rays at the lens 27, which causes the parallel rays to enter the liquid-crystal panel 30.

On the other hand, an image signal is inputted from the image input terminal 28. On the basis of the image signal, the liquid-crystal driver 29 drives the liquid-crystal panel 30. As a result, the light being
5 entered into the liquid-crystal panel 30 is spatially-modulated according to the image signal.

The spatially modulated light forms an image via the projection lens 31 on the screen 32. Red, green, and blue rays of light of about several watts are
10 needed for the light source of the projection-type image displaying apparatus. Use of the optical fiber laser shown in any one of the second to fifth embodiments enables such a light source to be realized at a low cost.

15 As described above, only the end part of the optical fiber 15 is deformed continuously, thereby converting the beam shape arbitrarily. When the processed part and the unprocessed part are constant in area, the divergence angle of light remains unchanged
20 at both of the parts.

With the feature, forming the incidence end part 16 of the optical fiber 15 into an ellipse makes it possible to cause the light emitted from the semiconductor laser 11 to enter the optical fiber 15 at a
25 high efficiency with a high light density. In addition, the output can be connected optically to an ordinary optical fiber whose core cross section is

round.

Furthermore, when a plurality of optical fibers 15 are bundled together and connected to one optical fiber 17, the end part of the optical fibers 15 bundled together is so processed that the external form cross section of the bundled optical fibers 15 has the same shape as that of the cross section of the optical fiber 17, which realizes optical connection between them at a high efficiency with a high light density.

Moreover, making use of this feature, it is possible to configure an optical fiber laser using the semiconductor laser 11 for excitation light, generate red, green, and blue rays of light of high output by wavelength up-conversion with the optical fiber laser, and use the optical fiber laser as a light source for the projection-type image displaying apparatus.

With the above configuration and method, the light emitted from the semiconductor laser is caused to enter a first optical fiber changed continuously from a specific position in the middle toward the incidence end in such a manner that the core shape at the incidence end becomes substantially elliptic, with the cross section remaining substantially unchanged. This enables the emitted light from the semiconductor laser to enter the optical fiber easily at a high efficiency with a high light density by use of a simple configuration. As a result, a highly efficient light

source is realized, which enables the image displaying apparatus to consume less power and reduces the manufacturing cost.

5 While the description above refers to particular embodiments of the present invention, it will be understood that many modifications may be made without departing from the spirit thereof. The accompanying claims are intended to cover such modifications as would fall within the true scope and spirit of the present invention. The presently disclosed embodiments are therefore to be considered in all respects as illustrative and not restrictive, the scope of the invention being indicated by the appended claims, rather than the foregoing description, and all changes that come within the meaning and range of equivalency of the claims are therefore intended to be embraced
10
15 therein.

As described in detail, with the present invention, it is possible to provide a semiconductor laser apparatus and a semiconductor laser control
20 method which enable the light emitted from a semiconductor laser to enter an optical fiber easily at a high efficiency with a high light density by use of a simple configuration. Furthermore, according to the present invention, an image displaying apparatus using
25 the semiconductor laser apparatus can be provided.